# **EPFL - CMi**

# **LAB 600 H**

# **WARNING**

Only the CMi Staff is qualified

- o to do a service
- o to do a maintenance
- o to fill or to exchange any source in a crucible.

Each user has to check by himself / herself

- o that the crucible configuration and indexing is correct
- o that the level of the evaporation source in the pocket of the crucible is enough

If the crucible configuration isn't correct, please contact the staff.

# User manual

# 1. Login

- 1.1. Logon on the ACCESS CONTROL SYSTEM.
- 1.2. Logon on the LAB 600 H: User → Change User → Select your login and type your password.

# 2. Loading

**2.1. VENT** (~5 min)

#### 2.2. ION SOURCE SHIELD

- Recipe without Ion Source (HRN, nSt, HHN,  $\dots$ ) => CHECK that the ion source is shielded with an aluminum foil.
- Recipe with Ion source (LRI, ...) => CHECK that the ion source isn't shielded (aluminum foil has been removed).

#### 2.3. CHECK THE CRUCIBLE CONFIGURATION

- See in the recipe list which crucibles are used.
- <u>IMPORTANT</u>: CHECK the crucible configuration through the transparent door of the box where evaporation sources are stored.

Example as shown in the picture:

- Crucible 1 = Al
- Crucible 2 = Cr
- Crucible 3 = Au
- Crucible 4 = "Coffre"
- Crucible 5 = Ti
- Crucible 6 = Pt



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# 2.4. INITIALIZE THE CRUCIBLE AND CHECK THE EVAPORATION SOURCES (crucible rotation in manual mode)

- "PROCESS" "PatternNo" : Select "Manual", then click "OK".
- EGC38 Module "SHUTTER": press the button "OPEN".
- EGC38 Module "CRUCIBLE": press the arrow key up or down until number 1 and wait until the number stops flashing.
- EGC38 Module "CRUCIBLE": press the arrow key up or down until number 6 and wait until the number stops flashing.
- EGC38 Module "CRUCIBLE": press the arrow key up or down until number 2 and wait until the number stops flashing. The crucible indexing is now initialized. CHECK that the Chromium pocket is shown (small grey pellets).



- EGC38 Module "CRUCIBLE": press the arrow key up or down until the desired pocket(s).
- **IMPORTANT**: CHECK the evaporation sources.
  - Material: color, appearance (SiO<sub>2</sub>: white grains, Au: yellow slug, Al<sub>2</sub>O<sub>3</sub>: white slug)
  - Level: check that the pocket isn't empty.
- EGC38 Module "SHUTTER": press the button "CLOSED".
- <u>IMPORTANT</u>: "PROCESS" "PatternNo": <u>Unselect</u> "Manual", then click "OK".
- EGC38 Module Check that the **green Led "REMOTE"** is ON.

#### 2.5. WAFER LOADING

- Put a dummy wafer in each ring you don't use.

#### 2.6. CLOSE the DOOR.

- Check the cleanness of the door O-ring.
- Clean the O-ring with your glove. Never use a solvent (isopropanol, acetone, ...)
- Close the door and lock it with the two bolts.

#### 2.7. HIGH VACUUM.

- Check the cleanness of the door O-ring.
- Clean the O-ring with your glove. Never use a solvent (isopropanol, acetone, ...).
- Close the door and lock it with the two bolts.

# 3. Recipe Configuration and Start

- 3.1. Modify recipe (thickness parameters)
  - **Recipe** → Select Category and Recipe.
  - Double click on "Write Data for Deposition" : Enter the thickness in kÅ.

# 3.2. Start recipe: Button « ON » + Select category and recipe + OK

- As soon as the pumping starts, the two bolts fall down.
- Leave the bolts as they are.
- Never put the bolts up when the chamber isn't at atmospheric pressure.

#### 3.3. Fill in the LAB 600 H notebook.

**3.4.** To stop a recipe: Button « Break ». Then call the staff because you have no rights to restart a recipe.

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# 4. Unloading

# **4.1. VENT** (~5 mn)

- The chamber can't be vented if the temperature is higher than 100°C.
- Wait 25 minutes after opening the door and before unloading your wafers.
  - Temperature near the heaters =  $120^{\circ}$ C at chamber opening.
  - Temperature near the heaters =  $80^{\circ}$ C 25 minutes later.
  - Temperature of the substrate holder = 100°C at chamber opening.
  - Temperature of the substrate holder =  $46^{\circ}$ C 25 minutes later.

#### 4.2. WAFER UNLOADING

- Put a dummy wafer in each ring after unloading your wafers.

#### 4.3. CLOSE the DOOR & HIGH VACUUM.

- Check the cleanness of the door O-ring.
- Clean the O-ring with your glove. Never use a solvent (isopropanol, acetone, ...).
- Close the door and lock it with the two bolts.
- Press the button "High Vacuum".

# 5. Logout

- **5.1.** Logout from the LAB 600 H: User → LOGOFF.
- **5.2.** Logout from the ACCESS CONTROL SYSTEM.